



MEMC 01-0151 (2960.1)
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Chang Bum Kim, et al.

Art Unit 1765

Serial No. 10/054,629

Filed January 22, 2002

Confirmation No. 5778

For THERMALLY ANNEALED, LOW DEFECT DENSITY SINGLE CRYSTAL
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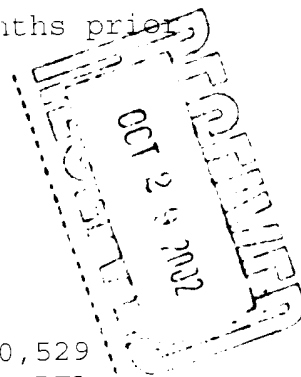
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicants submit copies of the references listed on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

I certify that each item contained in this statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

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**SUPPLEMENTAL INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

				Complete if Known	
				Application Number	10/054,629
				Filing Date	January 22, 2002
				Confirmation Number	5778
				First Named Inventor	Chang Bum Kim, et al.
				Group Art Unit	1765
				Examiner Name	
Sheet	1	of	1	Attorney Docket No.	MEMC 01-0151 (2960.1)

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
		Number	Kind Code ² (if known)				
FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office	Number ⁴	Kind Code ² (if known)			
	145	JP	11043396		Ohashi Wataru, et al.	02-16-1999	A
OTHER ART - NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.					T ⁶
	146	International Search Report, PCT/US 02/01782 dated September 20, 2002					

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Examiner Signature		Date Considered	
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